

RSH Series

高密度基板対応2D/3D検査装置
2D/3D inspection equipment for high-density substrates



超高速・高精度検査

High-Throughput & Accuracy

2D/3D同時測定システム

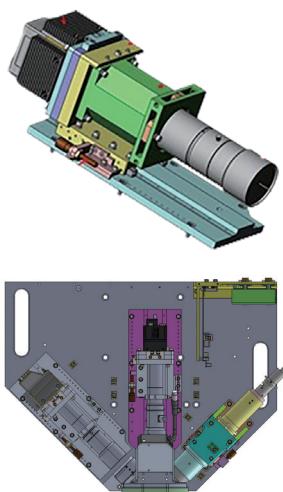
Simultaneous 2D/3D measuring system

バンプ径/ピッチ微細化対応

Compatible with finer bump diameter/pitch

お客様の用途に合わせ多彩なラインアップ

Diverse lineup to suit needs



三角測量法

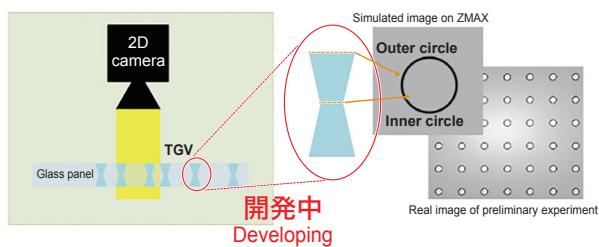
Laser Triangulation

	RSH-4	RSH-12	RSH-23	RSH-50
FOV (μm)	4	12	23	50
Minimum bump size (μm)	10	45	50	開発中 Developing
Minimum bump pitch (μm)	20	90	100	
3D Resolution (μm)	1.3	5	10	
2D Resolution (μm)	0.91	2.39	5.48	
Type of bumps	<ul style="list-style-type: none"> •Flip Chip flat/round bump, •Flip Chip top area/diameter, •CSP flat/round bump 		<ul style="list-style-type: none"> •Warpage inspection •SOP inspection •Passive component inspection •BGA 	

※上記の仕様外でもご相談ください。他のラインアップを取り揃えています。

Please contact us even if it is outside the specifications. We have other lineups.

開発中 | Developing



ガラスインター pocer の TGV 形状を検査

TGV shape inspection

